Application No.: 10/815,157 Docket No.: 07754/046001

## AMENDMENTS TO THE CLAIMS

Please amend the claims as follows.

1. (Original) A method for measuring high-energy radiation, comprising:

applying a voltage pulse to electrodes in an ion chamber filled with a gas capable of forming charged ions by the high-energy radiation;

measuring an ion current signal related to ion currents induced by the voltage pulse; and determining a magnitude of the high-energy radiation based on the ion current signal.

- 2. (Original) The method of claim 1, further comprising measuring a leakage current signal, wherein the determining the magnitude of the high-energy radiation comprises subtracting the leakage current signal from the ion current signal.
- 3. (Original) The method of claim 2, wherein the measuring the leakage current signal is performed after the voltage pulse is turned off.
- 4. (Original) The method of claim 2, further comprising determining a gain.
- 5. (Original) The method of claim 4, wherein the determining the gain comprises applying a ramping current to the electrodes in the ion chamber.
- 6. (Original) The method of claim 4, wherein the gain is used to adjust a magnitude of the ion current signal or a magnitude of the leakage current signal.
- 7. (Original) The method of claim 6, wherein the subtracting the leakage current signal from the ion current signal uses a magnitude-adjusted ion current signal or a magnitude-adjusted leakage current signal.
- 8. (Original) The method of claim 1, further comprising determining a gain, wherein the determining the magnitude of the high-energy radiation is based on the ion current signal and the gain.
- 9. (Original) The method of claim 8, wherein the determining the gain comprises applying a ramping current to the electrodes.
- 10. (Original) A system for measuring high-energy radiation, comprising:

140745

Application No.: 10/815,157 Docket No.: 07754/046001

an ion chamber having an ionizable material that can be ionized by the high-energy radiation;

two electrodes disposed in the ion chamber; and

- a circuit connected to the two electrodes, wherein the circuit is configured to provide a voltage pulse to the two electrodes and to measure an electrical signal across the two electrodes.
- 11. (Original) The system of claim 10, wherein the ionizable material comprises one selected from helium-3, boron trifluoride, lithium-6, uranium-233, uranium-235, and plutonium-239.
- 12. (Original) The system of claim 10, further comprising a target chamber comprising a hydrogenous material, wherein the target chamber is disposed proximate the ion chamber, and wherein the high-energy radiation comprises neutron radiation.
- 13. (New) A method for measuring high-energy radiation using the system of claim 10.

140745